

Title (en)
METHOD FOR MAKING COMPOSITE LAYERS

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Application
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Priority
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Abstract (en)
[origin: WO8403720A1] The method comprises the successive deposition of layers on top of each other, made from chemical compounds, the first layer (2) being deposited on a substrate (3), and is characterized in that each layer is deposited immediately after the preceding layer and in that the deposits of layers are carried out by reactive chemical spraying and at temperatures determined by the compounds to be deposited, a chemically inert atmosphere being maintained between each deposit. The device may comprise a moving furnace (9) communicating with the chambers (5a, 5b) respectively provided to deposit the different layers. Application to the making of electrodes for liquid medium display cells.

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